



PATENT
81839.0142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND
METHOD FOR PRODUCING
SILICON SINGLE CRYSTAL

Art Unit: 1722

Examiner: M. A. Anderson

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
first class mail in an envelope addressed
to:

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on
August 25, 2006

Date of Deposit

John P. Scherlacher, Reg. No. 23,009

Name

Signature Date

PETITION FOR EXTENSION OF TIME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this paper and every paper
referred to herein is being transmitted via facsimile
to recipient at 571) 273-8300 on:

August 25, 2006

Date of Facsimile Transmission

John P. Scherlacher, Reg. No. 23,009

Name

Signature Date

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a two-month extension of time extending to September 19, 2006,
the period for response to the Advisory Action dated August 2, 2006. Please charge
the fee of \$450 for this extension to Deposit Account No. 50-1314. The responsive
paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314. A copy of this petition is enclosed.

08/29/2006 MWOLDGE1 00000001 501314 10695609

01 FC:1252 450.00 DA

Date: August 25, 2006

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: John P. Scherlacher
John P. Scherlacher
Registration No. 23,009
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900
Los Angeles, California 90071
Phone: 213-337-6700
Fax: 213-337-6701